

專利公圖

字數  
(文) 4800+100

辦人 日期

ELECTRONIC PARTS AND METHOD PRODUCING THE SAME

[0001]

# BACKGROUND OF THE INVENTION

The present invention relates to electronic parts formed  
5 in a multilayer structure by use of a resin or a compound material  
made by mixing powder functional material into this resin, and  
to a method of producing the same.

[0002]

As a method of producing multilayer electronic parts by  
10 use of film conductors, JP-A-5-267063 discloses a method in Fig.  
5 of the drawings attached herewith. As shown in the same, for  
instance, in case of producing an inductor, powders of raw  
material are mixed for providing desired functions as ferrite  
(Step S1), and granulating and pulverizing are carried out (Step  
15 S2). Then, the substances mixed and regulated in predetermined  
grain diameter are turned out to be enamels by use of binder  
and solvent (Step S3).

[0003]

Laminating and baking steps carry out a screen printing  
20 (Step S4) of the ferrite paste, a pre-baking (Step S5) by rising  
temperature in a drying furnace, installation of inductor  
electrodes (Step S6) by forming the film through any of an  
evaporation, a sputtering and an ion plating, and a screen  
printing (Step S7) of the ferrite paste. These steps are repeated  
25 several times until obtaining patterns of desired number. The

forming of the electrode patterns is carried out simultaneously for many pieces of inductors.

[0004]

Thereafter, products are cut per each of chips (Step S8),  
 5 and the chips are formed on sides with external electrodes by coating, evaporation or sputtering (Step S9). Subsequently, other parts than the external electrodes are subjected to a silicone coating (Step S10), and if necessary, the external electrodes are subjected to an electroplating (Step S11).

10 [0005]

For producing the electronic parts having the film conductors formed by the evaporation by using a resin or a compound material made by mixing functional materials (dielectric powder or magnetic powder) with this resin, the multilayer electronic  
 15 parts are produced by repeating the printing of the functional material paste, the thermosetting and the film forming.

[0006]

[Problems that the Invention is to solve]

In case of producing the electronic parts by the procedure  
 20 of repeating the printing and the hardening as seen in the conventional examples, there have been problems that production cost is high, and a period till production is very long.

[0007]

In addition, in the case of ceramics, for printing or  
 25 forming the film conductor after baking, influences of fragility

of a prime body are easy to appear, or as stress is loaded thereon, problems about cracks or warp easily occur. Laminated layers are baked for hours by nature, and when the number of layer increases, a long production time and cost are consumed.

5 [0008]

Also in the case of the resin or the compound material, since the thermosetting and the printing are repeated to cause large stress loading thereon, the printed faces are roughened and when the number of layer increases, it becomes difficult  
10 to produce.

[0009]

#### SUMMARY OF THE INVENTION

In view of the above mentioned problems, it is an object of the invention to provide electronic parts and a method of  
15 producing the same in which the producing time is shortened, and crack or warp are hard to occur, reduction of cost can be attained, and the production can be performed even if the number of layer is many.

[0010]

20 A method of producing electronic parts of a first aspect of the invention is characterized by comprising: forming a resin or a compound material made by mixing powder-like functional materials with this thermosetting resin into thin plate, hardening it to be core substrates; forming film conductor on  
25 at least any of inside and outside surfaces of the core substrate

through any of an evaporation process, an ion plating process,  
an ion beam process, a vapor growth process, and a sputtering  
process, followed by patterning; forming the resin or the  
compound material made by mixing powder functional materials  
5 with this resin into the thin plates, alternately laminating  
half-hardened prepregs and the core substrates, and subsequently  
hot-pressing and unifying into multilayer parts.

[0011]

As seeing, if the core substrate and the prepreg are  
10 separately produced, and lamination and hardening are carried  
out concurrently, the production time can be shortened and the  
cost is lowered. Since the whole is once hardened by hot-pressing,  
crack or warp are hard to occur, and the production is possible  
even though the number of layer is many.

15 [0012]

Further, the film conductor can be made thin, so that it  
is possible to firstly make parts thin (in particular, this effect  
is remarkably in a capacitor), secondly heighten patterning  
precision and accuracy in layer-to-layer, and thirdly avoid  
20 migration because the film conductor is thin so that the resin  
is buried around its periphery. In this application, the term  
"powder-like" includes grain form, flake form, needle form, spike  
form, or the like.

[0013]

25 An electronic part of a second aspect of the invention

is characterized by comprising: a core substrate made by forming the resin or the compound material made by mixing the powder functional materials with this resin into thin plates, and hardening it; a film conductor formed on at least any of front  
5 and back surfaces of the core substrate through the film forming technique and carried out with the patterning; and an adhered layer formed with the thermosetting resin or the compound material made by mixing the powder functional material with this resin, and interposed among core substrates formed with  
10 the film conductors; wherein laminated layers made of the core substrates and the adhered layers are unified by hot-pressing.  
[0014]

If the electronic parts are composed of such a laminated structure, as mentioned in the first aspect, the production time  
15 can be shortened, the cost is lowered and crack or warp are avoided from occurrence.  
[0015]

The electronic part of a third aspect of the invention is, in the second aspect, that the film conductor has thickness  
20 less than 5  $\mu\text{m}$ .  
[0016]

When the thickness is more than 5  $\mu\text{m}$ , time is taken too much for forming the film, and it is difficult to shorten the production time. Because the thickness restricted less than  
25 5  $\mu\text{m}$ , it is possible to avoid the manufacturing time from becoming

long. In case of the thickness is less than 1  $\mu\text{m}$ , a conductor resistance becomes large. Therefore, in order to maintain a Q value at a predetermined level, thickness of the film conductor preferably has more than 1  $\mu\text{m}$ . However, in case of noise removing  
5 circuit which needs a capacitance or allows large loss, thickness of the thin film conductor may be less than 1  $\mu\text{m}$ , but more than 0.3  $\mu\text{m}$ .

[0017]

Moreover, according to the electronic part of the present  
10 invention, as a resin, at least one thermosetting resin selected from a group consisting of epoxy resin, phenol resin, unsaturated polyester resin, vinyl ester resin, polyimide resin, bismaleimidotriazine (cyanate ester) resin, polyphenylether (oxide) resin, fumarate resin, polybutadiene resin, and  
15 vinylbenzene resin, or at least one thermoplastic resin selected from a group consisting of aromatic polyester resin, polyphenylene sulfide resin, polyethylene terephthalate resin, polybutylene terephthalate resin, polyethylene sulfide resin, polyethyl ether ketone resin, polytetrafluorethylene resin,  
20 polyarylate resin and graft resin, or a composite resin composed of at least one of the thermosetting resin and at least one of the thermoplastic resin may be used.

[0018]

Moreover, according to the electronic part of the present  
25 invention, as the powder-like functional material, at least one

ferrite magnetic material selected from a group consisting of Mn-Mg-Zn based magnetic material, Ni-Zn based magnetic material, and Mn-Zn magnetic material, or at least one ferromagnetic metallic magnetic material selected from a group consisting of carbonyl iron, iron-silicon based alloy, iron-aluminum-silicon based alloy, iron-nickel based alloy, and amorphous (iron based or cobalt based) alloy, or at least one dielectric material selected from a group consisting of BaO-TiO<sub>2</sub>-Nd<sub>2</sub>O<sub>3</sub>, BaO-TiO<sub>2</sub>-SnO<sub>2</sub>, PbO-CaO, TiO<sub>2</sub>, BaTiO<sub>3</sub>, PbTiO<sub>3</sub>, SrTiO<sub>3</sub>, CaTiO<sub>3</sub>, Al<sub>2</sub>O<sub>3</sub>, BiTiO<sub>3</sub>, MgTiO<sub>3</sub>, (Ba, Sr)TiO<sub>3</sub>, Ba(Ti, Zr)O<sub>3</sub>, BaTiO<sub>3</sub>-SiO<sub>2</sub>, BaO-SiO<sub>2</sub>, CaWO<sub>4</sub>, Ba(Mg, Nb)O<sub>3</sub>, Ba(Mg, Ta)O<sub>3</sub>, Ba(Co, Mg, Nb)O<sub>3</sub>, Ba(Co, Mg, Ta)O<sub>3</sub>, Mg<sub>2</sub>SiO<sub>4</sub>, ZnTiO<sub>3</sub>, SrZrO<sub>3</sub>, ZrTiO<sub>4</sub>, (Zr, Sn)TiO<sub>4</sub>, BaO-TiO<sub>2</sub>-Sm<sub>2</sub>O<sub>3</sub>, PbO-BaO-Nd<sub>2</sub>O<sub>3</sub>-TiO<sub>2</sub>, (Bi<sub>2</sub>O<sub>3</sub>, PbO)-BaO-TiO<sub>2</sub>, La<sub>2</sub>Ti<sub>2</sub>O<sub>7</sub>, Nd<sub>2</sub>Ti<sub>2</sub>O<sub>7</sub>, (Li, Sm)TiO<sub>3</sub>, Ba(Zn, Ta)O<sub>3</sub>, Ba(Zn, Nb)O<sub>3</sub> and Sr(Zn, Nb)O<sub>3</sub>, or composite functional material composed of at least two of the above mentioned ferrite magnetic materials, ferromagnetic metallic magnetic materials, and dielectric materials may be used.

#### BRIEF DESCRIPTION OF THE DRAWINGS

Fig. 1 is a processing diagram showing one embodiment of the production method of the electronic parts according to the invention;

Figs. 2A to 2E are explanatory views of procedures of one parts practicing the production method of the electronic part according to the invention;

Figs. 3A to 3E are explanatory views of procedures of

remaining parts practicing the production method of the electronic part according to the invention;

Fig. 4A is a cross sectional view showing one example of the electronic part according to the invention, and Fig. 4B is  
5 a view of layer-structure; and

Fig. 5 is a procedure showing the conventional production method of the electronic part.

[0019]

#### DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

10 Fig. 1 is a processing diagram showing one embodiment of the production method of the electronic parts according to the invention, and Figs. 2 and 3 are explaining views illustrating respective steps.

[0020]

15 In the Step S1 of Fig. 1, for producing the compound material, the resin is added with the functional material (magnetic powder or dielectric powder) and a solvent such as toluene, and kneaded to make a paste. Herein, as the resins, at least one thermosetting resin selected from a group consisting of epoxy  
20 resin, phenol resin, unsaturated polyester resin, vinyl ester resin, polyimide resin, bismaleimidotriazine (cyanate ester) resin, polyphenyle ether (oxide) resin, fumarate resin, polybutadiene resin, and vinylbenzen resin, or at least one thermoplastic resin selected from a group consisting of aromatic  
25 polyester resin, polyphenylene sulfide resin, polyethylene



terephtharate resin, polybutylene terephthalate resin, polyethylene sulfide resin, polyethyl ether ketone resin, polytetrafluorethylene resin, polyarylate resin and graft resin, or a composite resin composed of at least one of the thermosetting resin and at least one of the thermoplastic resin may be used.

[0021]

The magnetic powder to be mixed with these resin is at least one ferrite magnetic material selected from a group consisting of Mn-Mg-Zn based magnetic material, Ni-Zn based magnetic material, and Mn-Zn magnetic material, or at least one ferromagnetic metallic magnetic material selected from a group consisting of carbonyl iron, iron-silicon based alloy, iron-aluminum-silicon based alloy, iron-nickel based alloy, and amorphous (iron based or cobalt based) alloy, or at least one dielectric material selected from a group consisting of BaO-TiO<sub>2</sub>-Nd<sub>2</sub>O<sub>3</sub>, BaO-TiO<sub>2</sub>-SnO<sub>2</sub>, PbO-CaO, TiO<sub>2</sub>, BaTiO<sub>3</sub>, PbTiO<sub>3</sub>, SrTiO<sub>3</sub>, CaTiO<sub>3</sub>, Al<sub>2</sub>O<sub>3</sub>, BiTiO<sub>3</sub>, MgTiO<sub>3</sub>, (Ba, Sr)TiO<sub>3</sub>, Ba(Ti, Zr)O<sub>3</sub>, BaTiO<sub>3</sub>-SiO<sub>2</sub>, BaO-SiO<sub>2</sub>, CaWO<sub>4</sub>, Ba(Mg, Nb)O<sub>3</sub>, Ba(Mg, Ta)O<sub>3</sub>, Ba(Co, Mg, Nb)O<sub>3</sub>, Ba(Co, Mg, Ta)O<sub>3</sub>, Mg<sub>2</sub>SiO<sub>4</sub>, ZnTiO<sub>3</sub>, SrZrO<sub>3</sub>, ZrTiO<sub>4</sub>, (Zr, Sn)TiO<sub>4</sub>, BaO-TiO<sub>2</sub>-Sm<sub>2</sub>O<sub>3</sub>, PbO-BaO-Nd<sub>2</sub>O<sub>3</sub>-TiO<sub>2</sub>, (Bi<sub>2</sub>O<sub>3</sub>, PbO)-BaO-TiO<sub>2</sub>, La<sub>2</sub>Ti<sub>2</sub>O<sub>7</sub>, Nd<sub>2</sub>Ti<sub>2</sub>O<sub>7</sub>, (Li, Sm)TiO<sub>3</sub>, Ba(Zn, Ta)O<sub>3</sub>, Ba(Zn, Nb)O<sub>3</sub> and Sr(Zn, Nb)O<sub>3</sub>, or composite functional material composed of at least two of the above mentioned ferrite magnetic materials, ferromagnetic metallic magnetic materials, and dielectric materials may be used.

For reducing the invention to practice, other thermosetting resin, magnetic powder and dielectric powder may be of course served.

[0022]

5 In the Step S2 of Fig. 1, the prepreg is made as shown in Fig. 2A. That is, a glass cloth coiled on a reel 3 is drawn out into a container 1 supporting the paste 2 of the compound material, and is immersed in the paste 2. Subsequently, the paste coated on the glass cloth 4 is dried by passing the glass  
10 cloth 4 through a dryer 5, and a blank material 7 is coiled on a coiling reel 6. Then, this blank material 7 is cut by a cutter 8 into desired sizes as shown in Fig. 2B, and glass-contained prepregs 9 are produced.

[0023]

15 The thus produced prepregs are divided into left-side Steps S3 to S6 of Fig. 1 and a right-side Step S7, and utilized as the core substrate 9a (see Fig. 2C) or as the prepreg 9b as a half hardened adhesive layer (see Fig. 2F). For forming the core substrate (Step S3), in case, e.g., the vinyl benzyl resin  
20 is used to the compound material paste, it is carried out at 200°C for 2 hours.

[0024]

As to the half-hardening of the prepreg 9b of Step S7, in case of using, for example, vinyl benzyl resin in the compound  
25 material 2, it is practiced at 110°C for 1 hour.

[0025]

In the film conductor forming process in Step S4, as shown in Fig. 2D, the film conductor 10 is formed on the inside and outside surfaces of the core substrate 9a through the film forming technique such as the evaporation process, the ion plating process, the ion beam process, the gaseous layer growth process, and the CVD process. In this case, as the film conductor 10, copper, silver, nickel, tin, zinc, or aluminum may be used.

[0026]

10 In the patterning process of Step S5, a resist is formed on the core substrate 9a, and passing through exposure for forming patterns of conductor layer thereafter, partial removal of the resist, film etching on the removed parts, and resist removing process, the patterned film conductors 11 are formed in Fig. 15 2E. The film conductors 11 are many on one sheet of core substrate 9a, and a plurality of the same patterns are arranged longitudinally and laterally. There is also the method of forming a thin film pattern through a mask as methods other than the above patterning process.

20 [0027]

In an inner via forming process of Step S6, as shown in Fig. 3A, via holes 12 are formed by drill, punching or laser, and the inner wall thereof is plated with the conductor 13, and the patterns 11, 11 on the inside and outside surfaces of the 25 core substrate 9a are connected each other. Thus, when plating

conductor 13 in the inner wall of a via hole 12, proper masking, such as a resist coating, is performed to thin film conductor 11 so as to not thicken the thickness of the conductor 11.

[0028]

- 5           In a unification press of Step S8, as shown in Fig. 3B, the core substrate 9a and the prepreg 9b as the adhesive layer are alternately laminated, and subjected to hot-pressing at substantially hardening temperatures and for time therefor, whereby the layer of the prepreg 9b is also substantially hardened.
- 10       Thus, the unified and laminated layers 14 are produced as shown in Fig. 3C.

[0029]

- In forming through-holes of Step S9, as shown in Fig. 3D, the through-holes 15 are formed by the drill, punching or laser
- 15       and the inner walls thereof are plated with the conductor 16, and the pattern 11-to-the pattern 11 on the inside and outside surfaces of the core substrate 9a or these inner patterns-to-the patterns 11, otherwise the inner pattern 11-to-the inner pattern 11 are connected each other.

20       [0030]

- In the plating - cutting in Step S10, the required plating as solder-plating is performed, followed by cutting into chips in pieces. As shown in Fig. 3E, when mounting parts 17, these parts 17 are soldered before or after cutting into pieces of
- 25       chips.

[0031]

The core substrate 9a and the prepreg 9b are separately made and laminated, and hardening are concurrently carried out, whereby the production time is shortened and the reduction of cost can be attained. In addition, as the whole is once hardened by the hot pressing, crack or warp are hard to occur. If the pattern 11 is formed by use of copper foil as conventionally, it is generally used a foil having thickness around 18  $\mu\text{m}$ . On the other hand, when the pattern is formed with the film conductor 11 as the invention, a film of lower than 9  $\mu\text{m}$  can be easily produced. Therefore, the laminated layers are less rugged by the thickness of the conductor 11, and properties when forming capacitors or inductors are little in dispersion.

[0032]

15 The thickness of the film conductor 10 is preferably less than 5  $\mu\text{m}$ . When the thickness of the film conductor 10 is more than 5  $\mu\text{m}$ , time is taken too much for forming the film, and it is difficult to shorten the production time. Because the thickness restricted less than 5  $\mu\text{m}$ , it is possible to avoid the manufacturing time from becoming long. In case of the thickness is less than 1  $\mu\text{m}$ , a conductor resistance becomes large. Therefore, in order to maintain a Q value at a predetermined level, thickness of the film conductor preferably has more than 1  $\mu\text{m}$ . However, in case of noise removing circuit which needs 25 a capacitance or allows large loss, thickness of the thin film

conductor may be less than  $1\mu\text{m}$ , but more than  $0.3\mu\text{m}$ .

[0033]

Fig. 4A is a cross sectional view showing one example of the electronic part according to the invention, and Fig. 4B is a view of layer-structure. This example is a voltage controlled oscillator (VCO), and 9a is the core substrate, 9b is the prepreg or a prepreg hardened and adhered to the core substrate 9a. Reference numeral 19 is a surface land pattern, 20 is capacitor electrodes, 21 is ground electrodes holding strip lines 22 composing a resonator therebetween. Reference numeral 17 is parts of semi-conductor such as transistors or variable capacitance diode, or mounted parts comprising capacitor of large volume, inductor chip, or chip resistor.

[0034]

The invention can be realized, other than the above mentioned examples, as a capacitor, inductor, LC filter, LCR filter or various kinds of modules in which semiconductor devices and passive parts (circuit) are combined, that is, hybrid integrated. For reducing the invention to practice, it is possible to realize such a structure of forming the film conductor only one side of the inside and outside surfaces of the core substrate 9a of one part or all parts composing the electronic part.

[0035]

According to the present invention, in comparison with

the conventional art in that copper foil is used, the film conductor of the present invention realizes to make electronic parts thin. Specifically, when the conventional electronic part include eight layers of 18 copper foil which is generally  
5 used as conductor pattern and seven resin layers as insulation layer each having 60 $\mu$ m thickness, the thickness of the electronic part is 564 $\mu$ m ( $60\mu\text{m} \times 7 + 18\mu\text{m} \times 8 = 564\mu\text{m}$ ).

[0036]

On the other hand, in the example of the invention, when  
10 the film conductor 11 has 3 $\mu$ m thickness, and the other conditions (thickness of the resin layer and numbers of resin layers and conductor layers) are the same, the thickness of the electronic part of the present invention is 444 $\mu$ m ( $60\mu\text{m} \times 7 + 3\mu\text{m} \times 8 = 444\mu\text{m}$ ). Thus, according to the invention, the electronic part  
15 thinner 120 $\mu$ m than the conventional can be obtained.

[0037]

Further, according to the conventional art, minimum conductor pattern width is about 50 $\mu$ m and minimum distance between patterns is also about 50 $\mu$ m. On the other hand, according  
20 to the present invention, minimum conductor pattern width is about 10 $\mu$ m and minimum distance between patterns is also about 10 $\mu$ m. Thus, the conductor pattern can be fine and pattern accuracy also can be improved.

[0038]

25 According to the invention, as the core substrate and the

prepreg are separately formed, and at the same time laminated and hardened to produce the electronic part, the production time is shortened and the cost-down can be attained. As the whole is once hardened by the hot pressing, crack or warp are hard  
5 to occur. By making the conductor thin, it is possible to make the patterns fine and parts thin, heighten patterning precision and accuracy in layer-to-layer, and avoid migration.

[0039]

According to the invention, the film conductor is made  
10 less than 5  $\mu\text{m}$  in thickness, so that the conductor thickness is not large, it is possible to avoid the time from becoming long.